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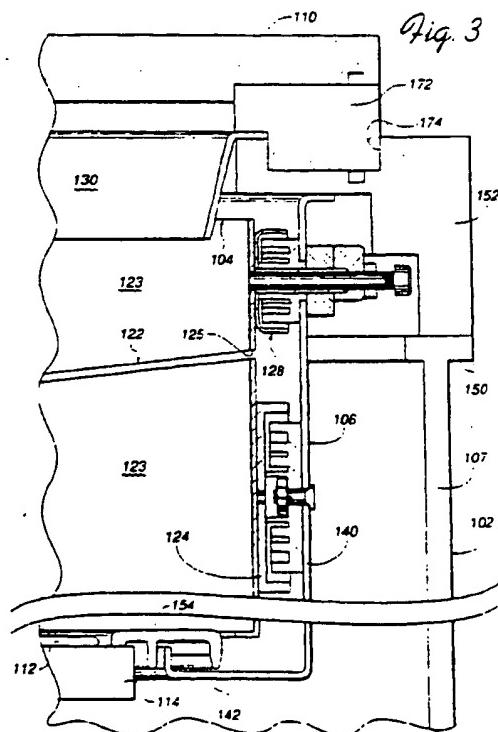
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(54) Active shield for generating a plasma for sputtering

(57) A combination coil and shield (104) for a plasma chamber (100) in a semiconductor fabrication system is provided. The coil-shield has a plurality of turns

to couple energy efficiently into a plasma and also substantially blocks deposition material from reaching a second shield (106) positioned behind the first shield



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EUROPEAN SEARCH REPORT

Application Number

EP 97 30 7864

DOCUMENTS CONSIDERED TO BE RELEVANT			CLASSIFICATION OF THE APPLICATION (Int.Cl.6)						
Category	Citation of document with indication, where appropriate of relevant passages	Relevant in claim:							
D,P.	EP 0 774 886 A (APPLIED MATERIALS INC) 21 May 1997	1,4-6, 10-12, 15-17, 27-30	H01J37/34 H01J37/32						
P,Y	* page 5, line 33 - page 6, line 50 * * page 7, line 49 - page 8, line 46; figures 3.6.7 *	19.20							
Y	US 4 568 845 A (UEHARA KENJI) 4 February 1986 * column 3, line 11 - line 26; figure 3 *	19.20							
A	EP 0 593 924 A (LEYBOLD AG) 27 April 1994 * column 2, line 35 - column 3, line 40; figure 1 *	1.10,27							
			TECHNICAL FIELDS SEARCHED (Int.Cl.6)						
			H01J						
<p>The present search report has been drawn up for all claims</p> <table border="1" style="width: 100%; border-collapse: collapse;"> <tr> <td style="width: 33%;">Place of search</td> <td style="width: 33%;">Date of completion of the search</td> <td style="width: 33%;">Examiner</td> </tr> <tr> <td>THE HAGUE</td> <td>17 July 1998</td> <td>Schaub, G</td> </tr> </table>				Place of search	Date of completion of the search	Examiner	THE HAGUE	17 July 1998	Schaub, G
Place of search	Date of completion of the search	Examiner							
THE HAGUE	17 July 1998	Schaub, G							
CATEGORY OF CITED DOCUMENTS		T theory or principle underlying the invention E earlier patent document but published on or after the filing date D document cited in the application L document cited for other reasons S member of the same patent family; corresponding document							
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